



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Group Art Unit: 2822  
Examiner: Bach Au  
Confirmation No.: 9107

**In Re PATENT APPLICATION Of:**

**Applicant : Hiroomi Tsutae**

**Serial No. : 10/657,207**

Filed : September 9, 2003

For : PROCESS OF CLEANING A  
SEMICONDUCTOR MANUFACTURING  
SYSTEM AND METHOD OF  
MANUFACTURING A SEMICONDUCTOR  
DEVICE

Attorney Ref.: FUJI 136

) RESPONSE TO  
 ) ELECTION/RESTRICTION  
 ) REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

Responsive to the Election/Restriction Requirement mailed on May 1, 2008, Applicant elects Invention I, i.e. the subject matter of claims 1-3 and 18-19, for further examination. The election is made without traverse.

Examination of the application on the merits respectfully is requested.

Respectfully submitted,

March 21, 2008  
Date

  
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